



FORM PTO-1083

In RE application of S. KONDO et al

Serial No.: 09/637,570 ✓

Filed: August 14, 2000

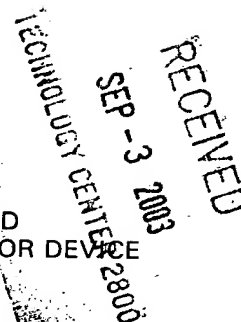
For: POLISHING METHOD, METALLIZATION FABRICATION METHOD, METHOD  
FOR MANUFACTURING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR DEVICE

PATENT

Case Docket No. NIT-215

Group Art Unit: 2812

Examiner: Ha T. Nguyen

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☐ Small entity status of this application under 37 CFR 1.9 and 1.27 has been established by a verified statement previously submitted.
- ☐ A verified statement to establish small entity status under 37 CFR 1.9 and 1.27 is enclosed.
- ☒ No additional fee is required.

The fee has been calculated as shown below:

|  | (COL. 1)                                  |       | (COL. 2)                              |   | (COL. 3)         |
|--|---|-------|---------------------------------------|---|------------------|
|  | Claims<br>Remaining<br>After<br>Amendment |       | Highest No.<br>Previously<br>Paid For |   | Present<br>Extra |
| Total  | * 21                                      | Minus | ** 23                                 | = | 0                |
| Indep.   | * 7                                       | Minus | *** 9                                 | = | 0                |
| <input type="checkbox"/> First Presentation of Multiple Dependent Claims |   |       |                                       |   |                  |

## SMALL ENTITY

| Rate  | Additional<br>Fee |
|-------|-------------------|
| x 9   | \$                |
| x 42  | \$                |
| + 140 | \$                |
| Total | \$                |

OR

OTHER THAN A  
SMALL ENTITY

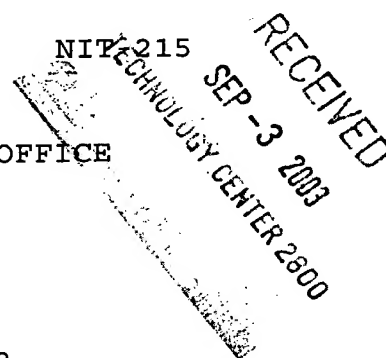
| Rate  | Additional<br>Fee |
|-------|-------------------|
| x 18  | \$ 0              |
| x 84  | \$ 0              |
| + 280 | \$ 0              |
| Total | \$ 0              |

- \* If the entry in Col. 1 is less than the entry in Col. 2, write '0' in Col. 3.
- \*\* If the 'Highest Number Previously Paid For' IN THIS SPACE is less than 20, write '20' in this space.
- \*\*\* If the 'Highest Number Previously Paid For' IN THIS SPACE is less than 3, write '3' in this space.
- The 'Highest Number Previously Paid For' (Total or Independent) is the highest number found from the equivalent box in Col. 1 of a prior Amendment or the number of claims originally filed.

- ☐ Please charge my Deposit Account No. 50-1417 in the amount of \$ \_\_\_\_\_.
- ☐ A check in the amount of \$ \_\_\_\_\_ is attached in payment of: \_\_\_\_\_.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 50-1417.
- ☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
- ☒ Any patent application processing fees under 37 CFR 1.17.
- ☒ Any Extension of Time fees that are necessary, which are hereby requested if necessary.

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Attorney for Applicant(s)

Date: August 26, 2003



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

S. KONDO et al

Serial No. 09/637,570

Group Art Unit: 2812

Filed: August 14, 2000

Examiner: Ha T. Nguyen

For: POLISHING METHOD, METALLIZATION FABRICATION  
METHOD, METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE AND SEMICONDUCTOR DEVICE

AMENDMENT

Commissioner for Patents  
Alexandria, VA 22313

Sir:

In response to the Office Action dated May 29, 2003,  
please amend the above-identified application as follows.